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SERIAL NUMBER 10/714,644	FILING DATE 11/18/2003  RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. 117787
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APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* NONE T.O

\*\* FOREIGN APPLICATIONS \*\*\*\*\* T.O  
 JAPAN 2002-335,165 11/19/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\* SMALL ENTITY \*\*  
 \*\* 02/27/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 4	TOTAL CLAIMS 15	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: _____				

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 25944  
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TITLE  
 Method for fabricating a SiGe film, substrate for epitaxial growth and multilayered structure

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